



**ELECTRONIC COPY**

LG766644333  
Report verification at igi.org



February 13, 2026  
IGI Report Number **LG766644333**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **CUT CORNERED  
RECTANGULAR MODIFIED  
BRILLIANT**  
Measurements **7.46 X 5.21 X 3.39 MM**  
**GRADING RESULTS**  
Carat Weight **1.12 CARAT**  
Color Grade **E**  
Clarity Grade **VVS 2**

**LABORATORY GROWN DIAMOND REPORT**

February 13, 2026  
IGI Report Number **LG766644333**  
Description **LABORATORY GROWN DIAMOND**  
Shape and Cutting Style **CUT CORNERED RECTANGULAR  
MODIFIED BRILLIANT**  
Measurements **7.46 X 5.21 X 3.39 MM**

**GRADING RESULTS**

Carat Weight **1.12 CARAT**  
Color Grade **E**  
Clarity Grade **VVS 2**

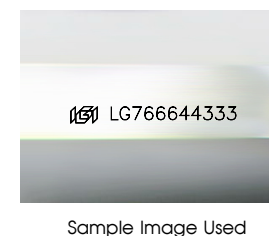
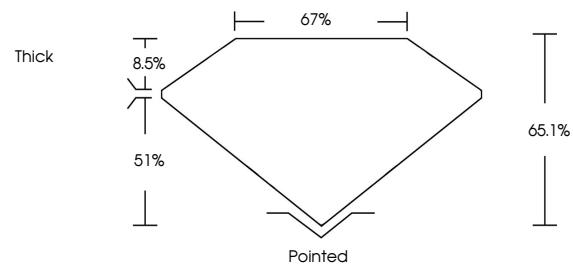
**ADDITIONAL GRADING INFORMATION**

Polish **VERY GOOD**  
Symmetry **VERY GOOD**  
Fluorescence **NONE**

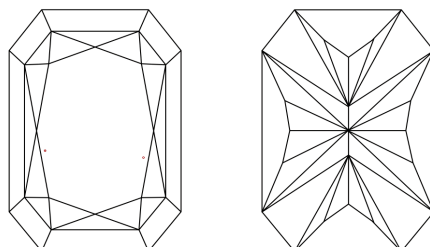
Inscription(s) **IGI LG766644333**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa

**PROPORTIONS**



**CLARITY CHARACTERISTICS**



**KEY TO SYMBOLS**

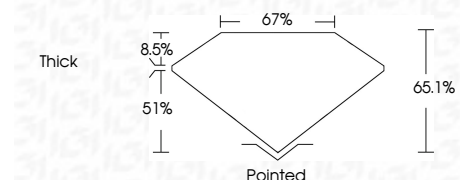
Red symbols indicate internal characteristics.  
Green symbols indicate external characteristics.

**COLOR**

D E F G H I J Faint Very Light Light

**CLARITY**

FL	IF	VVS <sup>1-2</sup>	VS <sup>1-2</sup>	SI <sup>1-2</sup>	I <sup>1-3</sup>
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



**ADDITIONAL GRADING INFORMATION**

Polish **VERY GOOD**  
Symmetry **VERY GOOD**  
Fluorescence **NONE**  
Inscription(s) **IGI LG766644333**  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa



February 13, 2026  
IGI Report No LG766644333  
CUT CORNERED RECT. MODIFIED BRILLIANT  
7.46 X 5.21 X 3.39 MM  
1.12 CARAT  
E  
VVS 2  
65.1%  
67%  
Thick  
Pointed  
Polish  
VERY GOOD  
Symmetry  
VERY GOOD  
Fluorescence  
NONE  
Inscription(s)  
IGI LG766644333  
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.  
Type IIa